



Attorney Docket No: 203.73

PATENT *FFW*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

V. Sivaramakrishnan et al.

Application No.: 10/817,396

Filing Date: April 2, 2004

For: VAPORIZING REACTANT
LIQUIDS FOR CHEMICAL
VAPOR DEPOSITION FILM
PROCESSING

) Group Art Unit: 2932

) Examiner: Bushey, Charles S.

) **REQUEST FOR A THREE MONTH
EXTENSION OF TIME TO RESPOND**

CERTIFICATE OF MAILING

I hereby certify that the correspondence enclosed herein is being deposited as first class mail with the United States Postal Service on this date, November 18, 2005 in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

By: *Teri Nelmark*
Teri Nelmark

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant hereby petitions for a three month Extension of Time to answer the outstanding Official Action mailed May 24, 2005 regarding the above-referenced patent application. Please find enclosed a check in the amount of \$1,020.00 to cover the Extension of Time fee.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment to Deposit Account No. 04-0822. A duplicate copy of this sheet is submitted.

11/22/2005 ZJUHR1 00000037 040822 10817396
01 FC:1253 1020.00 OP

Respectfully submitted,
DERGOSITS & NOAH LLP

Dated: Nov. 18, 2005

By: *Samuel S. Lee*
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